

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/029,144	KIM ET AL.		
Examiner	Art Unit		
Mike Qi	2871		

SEARCHED					
Class	Subclass	Date	Examiner		
349	43,143; 187	8/7/2006	ZQQ		
204	192.29;	8/7/2006	ZQQ		
204	192.35	8/7/2006	ZQQ		
205	223	8/7/2006	ZQQ		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
349	(43)	8/7/06	700	
>04	192.29			
205	227			
interferer	nce query		<b>*</b>	

SEARCH NO (INCLUDING SEARCH		)
	DATE	EXMR
East search; US-PGPUB;USPAT;USOCR; EPO;JPO;DERWENT;IBM_TDB; (see search history printout)	8/7/2006	ZQQ
East search update searched in the above data bases; (see printout) interference search; (see printout)	8/7/2006	ZQQ